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Attorney Docket No.: 12732-0171001 / US6695

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Masaharu Nagai et al. Art Unit : 1795
Serial No. : 10/694,986 Examiner : Daborah Chacko Davis
Filed : October 29, 2003 Conf. No. : 5334
Title : METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF OCTOBER 8, 2009

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.